

Request for Endorsement of a Conference/ Meeting by IUVSTA

Please complete this form and return it to the Secretary General

TITLE OF EVENT

VENUE.....

DATES.....

PRINCIPAL THEMES OF THE EVENT

.....

Circle the name of the appropriate IUVSTA Division: Applied Surface Science; Electronic Materials & Processing; Nanometer Structures; Plasma Science and Technique; Surface Science; Thin Film; Vacuum Metallurgy; Vacuum Science

Expected Attendance: Number

Nationalities

Are abstracts and other communications in English, French or German?..... (Yes/No)

Exhibition arrangements (if any)

NAMES AND NATIONALITIES OF INVITED SPEAKERS (if any)

.....
.....

NAMES OF OTHER SPONSORS and ENDORSERS (actual and applied for)

.....
NAMES AND NATIONALITIES OF PROGRAMME COMMITTEE.....(Separate Sheet)

With contact addresses

CHAIR

CHAIR OF SCIENTIFIC/PROGRAMME CTTEE

Website url:

Name/ e-mail address of person who will maintain the site:

UNDERWRITING: Who will underwrite any financial loss?